

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 7,498,124 B2
APPLICATION NO. : 10/675419
DATED : March 3, 2009
INVENTOR(S) : John M. Kulp

Page 1 of 1

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

On the Title Pg Item (57) ABSTRACT, "A method and apparatus for" should read --A method for--.

Col. 1, lines 36-37, "spin-drying in this case," should read --spin-drying. In this case,--.

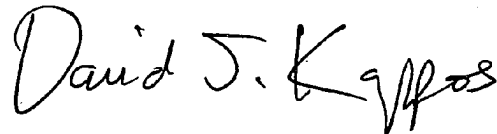
Col. 9, line 14, "i.e., subjected a surfactant-containing" should read --i.e., subjected to a surfactant-containing--.

Col. 13, line 7, Claim 1, "applying the resist film surfactant-containing" should read --applying the sacrificial surfactant-containing--.

Col. 13, line 8, Claim 1, "the substrate to displace" should read --the resist film to displace--.

Signed and Sealed this

Twenty-ninth Day of December, 2009

A handwritten signature in black ink that reads "David J. Kappos". The signature is written in a cursive, flowing style with a large initial 'D' and a stylized 'K'.

David J. Kappos
Director of the United States Patent and Trademark Office